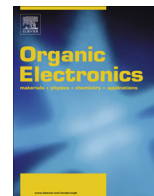




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Nonvolatile memory and opto-electrical characteristics of organic memory devices with zinc oxide nanoparticles embedded in the tris(8-hydroxyquinolino)aluminum light-emitting layer

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ABSTRACT

The nonvolatile organic memory devices based on the tris(8-hydroxyquinolino)aluminum (Alq₃) emitting layer embedded with zinc oxide nanoparticles (ZnO-NPs) are reported. The devices have a typical tri-layer structure consisting of the Alq₃/ZnO-NPs/Alq₃ layers interposed between indium tin oxide (ITO) and aluminum (Al) electrodes. An external bias is used to program the ON and OFF states of the device that are separated by a four-orders-of-magnitude difference in conductivity. No significant degradation of the device is observed in either the ON or OFF state after continuous stress ($\sim 10^5$ s) and multicycle ($\sim 10^3$ cycles) testings. These nanoparticles behave as the charge trapping units, which enable the nonvolatile electrical bistability when biased to a sufficiently high voltage. Impedance spectroscopy, capacitance–voltage (C–V) and current–voltage (I–V) analysis are used to verify the possible physical mechanism of the switching operation. Moreover, it is found that the location of the ZnO-NPs could affect the memory and opto-electrical characteristics of the devices, such as the ON/OFF ratio, threshold voltage and turn-on voltage, which can be attributed to the influence of the ZnO-NPs and diffused Al atoms in the bulk of the Alq₃ layer.

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1. Introduction

Organic materials have attracted considerable attention due to their potential applications in next-generation electronic and optoelectronic devices operating at low powers [1,2]. As one of the significant electronic devices, nonvolatile organic memory device is very promising in next-generation memory applications because of the distinctive advantages of low-power consumption, ultrahigh-density storage, high mechanical flexibility, low cost, and simple fabrication [3,4]. Therefore, with the rapid development of organic memory technology, a lot of effort has been made to improve organic memory device structures and to understand their operating mechanisms.

A number of device structures of the nonvolatile organic memory have been manufactured and extensively explored, such as a single-layer structure consisting of only one type of organic material [5,6], a tri-layer structure in which nano-traps for charge carriers are sandwiched between two organic layers [7,8], and a spin-cast blend of polymer and nano-traps in which nano-traps are randomly dispersed in the polymer layer [9–16]. Because the charges stored

inside the nano-traps can efficiently change the conductivity of the organic layer, finding appropriate materials to produce the nano-traps has been the major issue in the tri-layer or hybrid composite structures of the organic memory. So far various kinds of nano-traps materials employed in nonvolatile organic memory devices utilizing sandwich or blend structures have been reported, such as metal nanoparticles [8,10,11], semiconductor nanoparticles [12–14], grapheme [9], fullerene (C₆₀) nanoparticles [15], or core/shell CdSe/ZnS nanoparticles [16].

Among the several types of nano-traps materials, Zinc oxide (ZnO) is a promising material as it is an abundant material with non-toxic, cheap, mechanically flexible and optically transparent [17]. A simple ZnO nanostructure, nanoparticles or nano-powder, has been successfully applied in organic optoelectronics due to their excellent optical, electrical, mechanical and chemical properties [17,18]. For organic memory application, some studies concerning the fabrication and the electrical properties of memory devices with hybrid composites containing ZnO nanoparticles (ZnO-NPs) blended with a polymer layer have been carried out [19,20]. However, studies on the electrical bistabilities, the memory stabilities, and the memory mechanisms in nonvolatile organic memory devices made of ZnO-NPs embedded in a small-molecule layer of tris(8-hydroxyquinolino) aluminum (Alq₃) layer have not

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85 been reported yet. The material of Alq₃ has been studied as an
 86 organic semiconductor, which are popularly used as an electron
 87 transport layer and a light-emitting layer in organic light-emitting
 88 diodes (OLEDs) [21]. Organic-light emitting bistable memory
 89 devices with a dual function of a nonvolatile memory and light-
 90 emitting devices are recently developed for versatile applications
 91 [22,23]. It is thus important to investigate on both the electrical
 92 switching and opto-electrical characteristics of the Alq₃-based
 93 organic memories with the ITO electrode. In this paper, we
 94 fabricated and investigated nonvolatile organic memory devices
 95 consisting of Alq₃ layers embedded with ZnO-NPs. The ZnO-NPs
 96 were deposited within the Alq₃ layers by thermally evaporation.
 97 These ZnO-NPs then act as efficient charge storage medium. We
 98 characterized the fabricated organic memory devices in terms of
 99 their electrical bistability, data retention and cycling endurance
 100 properties, and opto-electrical characteristics.

101 2. Experimental details

102 The nonvolatile organic memory devices proposed in this study
 103 consists of an organic/metal-oxide/organic tri-layer structure
 104 interposed between indium tin oxide (ITO) and aluminum (Al)
 105 electrodes, as shown in Fig. 1(a). The simple cross-bar memory
 106 device was fabricated as follows. First, x-nm-thick Alq₃, 1.5-nm-
 107 thick ZnO, and (140-x)-nm-thick Alq₃ thin films were evaporated
 108 in sequence onto a cleaned ITO/glass substrate. A very thin ZnO
 109 film deposited by thermal evaporation from ZnO powders (purity:
 110 99.99%, purchased from Sigma-Aldrich Co.) is able to form a dis-
 111 continuous layer of ZnO-NPs on our used organic film. The thick-
 112 ness of the Alq₃ and ZnO layers was controlled by a calibrated
 113 quartz crystal oscillator and their deposition rate was maintained
 114 at 0.1 and 0.01 nm/s, respectively. Finally, a 100-nm-thick Al
 115 thin film was evaporated through a metal mask as the top electrode,
 116 resulting in the ITO/Alq₃ (x nm)/ZnO (1.5 nm)/Alq₃ (140 - x nm)/
 117 Al (100 nm) structure of organic memory devices. For comparison,
 118 the single-layer organic memory devices with ITO/Alq₃ (140 nm)/
 119 Al (100 nm) were also fabricated. All materials were evaporated
 120 at a vacuum pressure under 3.0×10^{-6} torr at room temperature.
 121 The thickness of the films was determined *in situ* by a quartz-crys-
 122 tal sensor and *ex situ* by a surface profiler (Tencor Alpha-step IQ).
 123 The active area of the device was 2.5×2.5 mm².

124 The surface morphology and chemical compositions of the films
 125 were characterized by atomic force microscopy (AFM, Veeco
 126 Instrument, Santa Barbara, CA) and X-ray photoelectron spec-
 127 troscopy (XPS, VG Scientific, Sigma Probe). The current–voltage
 128 (*I*–*V*) curves, the write-read-erase-read cycles and the data reten-
 129 tion characteristics of the devices were measured using a source
 130 meter (Keithley 2400) controlled by a computer. Impedance spec-
 131 troscopy and capacitance–voltage (*C*–*V*) characteristics were car-
 132 ried out using an impedance analyzer (Wayne Kerr 6500B),
 133 whose frequency range was 20 Hz to 20 MHz. Luminance–voltage
 134 (*L*–*V*) characteristics of the devices were measured with a source
 135 meter and a luminance meter (LS-100). All measurements were
 136 carried out at room temperature under ambient conditions.

137 3. Results and discussion

138 3.1. Morphology and compositions of ZnO-NPs

139 The AFM image for the surface morphology of the 1.5-nm-thick
 140 ZnO interlayer deposited on the Alq₃ film is shown in Fig. 1(b). It
 141 can be clearly seen that the nanoparticles were randomly dis-
 142 tributed on the surface of the Alq₃ layer. In general, layers less than
 143 10-nm-thick show a granular structure and a discontinuous profile.
 144 The particle size was approximately estimated in the range of

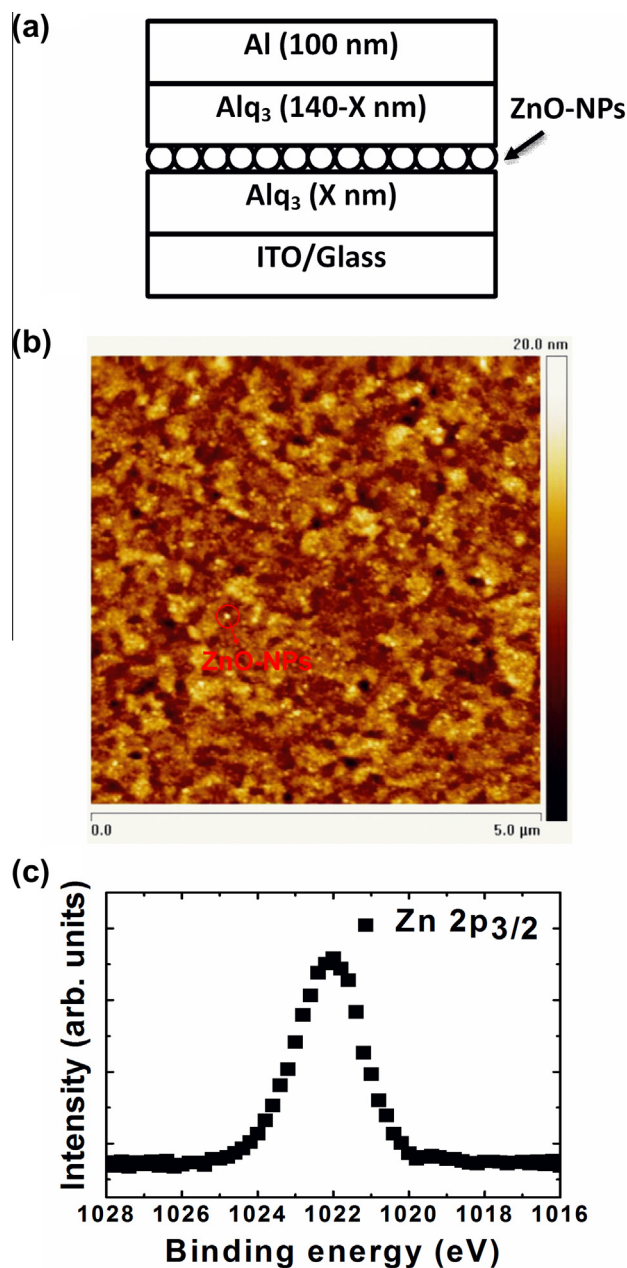


Fig. 1. (a) Schematic structure of the organic memory devices with ZnO-NPs. (b) AFM image and (c) Zn 2p_{3/2} core-level XPS spectra of the 1.5-nm-thick ZnO interlayer deposited on the Alq₃ film.

145 30–60 nm due to some aggregation of nanoparticles. In addition,
 146 the chemical compositions of ZnO-NPs were further examined
 147 with XPS and Zn 2p_{3/2} spectrum is presented in Fig. 1(c). The Zn
 148 2p_{3/2} spectrum peaked at around 1022.0 eV, which can be attrib-
 149 uted to the formation of ZnO rather than metallic Zn because the
 150 binding energy of the Zn–O bond (1021.9 eV) is higher than that
 151 of the Zn–Zn bond (1021.4 eV) [24]. The results confirm that there
 152 are ZnO-NPs being created from thermal evaporation.

153 3.2. *I*–*V* characteristics

154 The typical *I*–*V* characteristics for the ITO/Alq₃ (70 nm)/ZnO-
 155 NPs/Alq₃ (70 nm)/Al (100 nm) device structure were measured
 156 from 0 to 10 V and then from 10 to –10 V, as shown in Fig. 2(a).
 157 During the first bias scan, a low current was observed in the bias

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